



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Seung-un KIM, et al.

Art Unit 1763

Serial No. 10/800,735

Confirmation No. 1171

[Division of Serial No. 10/084,198, filed February 28, 2002]

Filed: March 16, 2004

For: APPARATUS AND METHOD FOR SUPPLYING CHEMICALS
IN CHEMICAL MECHANICAL POLISHING SYSTEMS

RESPONSE

to NOTICE OF NON-COMPLIANT AMENDMENT

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENT(S)

In response to the Official Action mailed June 23, 2004, a substitute listing of claims (which begins on page 2 of this paper) is submitted.

Remarks are on page 4 of this paper.